

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of

FUKUOKA ET AL.

Atty. Ref.: 900-556

Appl. No. Unknown

TC/A.U. Unknown

Filed: July 12, 2006

Examiner: Unknown

For: SEMICONDUCTOR MANUFACTURING APPARATUS AND SEMICONDUCTOR  
MANUFACTURING METHOD USING THE SAME

\* \* \* \* \*

July 12, 2006

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PRELIMINARY AMENDMENT**

In order to place the above-identified application in better condition for  
examination, please amend the application as follows: